



IFW

PATENT
81788.0257

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Ichiro Uchizaki, et al.

Serial No: 10/664,002

Filed: September 16, 2003

For: SEMICONDUCTOR LASER ARRAY AND ITS
MANUFACTURING METHOD, OPTICAL
INTEGRATED UNIT AND OPTICAL PICKUP

Art Unit: 2828

Confirmation No.: 3909

Examiner: Not Assigned

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

June 21, 2005

Date of Deposit

William H. Wright, Reg. No. 36,312

Name

Signature

Date

STATUS REQUESTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The above-referenced application was filed on September 16, 2003 and the Notice of Publication of Application was received on April 13, 2004. To date, no further papers have been received in this case.

Please send the undersigned a Status Report on this application.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: June 21, 2005

By: 

William H. Wright

Registration No. 36,312

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